

PATENT Customer No. 22,852 Attorney Docket No. 04329.3238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:)
	Gaku Minamihaba et al.) Group Art Unit: 2818
Application No.: 10/771,060) Examiner: Goodwin, David J.
Filed:	February 4, 2004)
For:	POLISHING PAD AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICES	Confirmation No.: 2231
P.O.	missioner for Patents Box 1450 Indria, Virginia 22313-1450	

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a one month extension of time to reply to the Office Action mailed January 23, 2007. A fee of \$120.00 is enclosed.

Please grant any additional extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: May 23, 2007

Selah C. Park Reg. No. 57,127

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